

# FORM PTO-1449 TO BE FILED WITH INFORMATION DISCLOSURE STATEMENT

U.S. Department of Commerce

Patent and Trademark Office

Atty. Docket No.: OSU1159-141H

Application No.: 10/754,410 Filing Date: January 9, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

BY APPLICANT

Applicant: McCreery Group Art Unit: 2818 Examiner: David Nhu

#### **U.S. PATENT DOCUMENTS**

Examiner's	Document			Class/
Initial/	Number	Date	Name(s)	Sub-class
\$n	5,520,968	5/28/1996	Wynne et al.	428/1
\	6,855,417	2/15/20056	McCreery	428/338
	6,855,950	2/15/2005	McCreery	257/40
Da	6,919,128	7/19/2005	McCreery	428/333

### **FOREIGN PATENT DOCUMENTS**

Examiner's Initial	Document Number	Date	Name(s)	Translation
Da ,	JP 9-219395	8/19/1997	Watabe et al.	Yes (Abstract)
PA	JP 9-307157	11/28/1997	Mitsuya et al.	Yes (Abstract)

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DISCLOSURE STATEMENT

Group Art Unit: 1773

BY APPLICANTS

Examiner: Not Known

### **U.S. PATENT DOCUMENTS**

Examiner's Initial	Document Number	Date	Name	Class/Sub- class
1	5,208,154	5/4/1993	Weaver et al.	435/176

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Source of References Cited

Application/Control No.

09/755,437

Examiner

Ramsey Zacharia

Applicant(s)/Patent Under
Reexamination
MCCREERY, RICHARD L.

Page 1 of 1

### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
7	Α	US-5,208,154	05-1993	Weaver et al.	435/176
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### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

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Notice of References Cited

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Applicant: McCreery

DISCLOSURE STATEMENT

Group Art Unit: 2818
Examiner: Ngan V. Ngo

BY APPLICANT

### **U.S. PATENT DOCUMENT**

Examiner's	Document			Class/Sub-
Initial	Number	Date	Name(s)	class
32	6,114,099	9/2000	Liu et al.	430/324

### FOREIGN PATENT DOCUMENT

Examiner's Initial	Document Number	Date	Name(s)	Translation
	WO 92/13983 A1	8/1992	Pinson et al.	Yes (Abstract)

Examiner & AWR	Date Considered	9/	6/05
			7

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Group Art Unit: 1773

BY APPLICANTS

**Examiner: Not Known** 

U.S. PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Name	Class/Sub-
pn/	6,046,925	4/4/2000	Tsien et al.	365/111
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Examiner & W. P. C.	Date Considered	9/6/05
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BY APPLICANTS	January 9, 2004 Filing Date	Group Art Unit	
		Examiner's name	

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Examiner's Initial	Document Number	Date	Name	Class/Sub-
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· \$20	5,908,692	06/01/1999	Hamers et al.	428/333

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